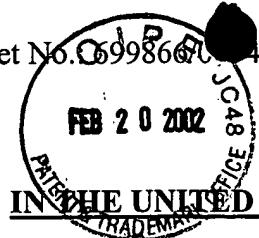


Atty. Docket No. 0699867004
LR:DMF



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Applicants: Hisashi Ohtsuka et al.

Serial No.: 09/552,540

Art Unit: 2881

Filed: April 19, 2000

Examiner: C. Harmon

For: SOLID-STATE LASER APPARATUS EXCITED BY LASER
LIGHT FROM SEMICONDUCTOR

February 4, 2002

PETITION FOR EXTENSION OF TIME
PURSUANT TO 37 C.F.R. §1.136(a) AND FEE AUTHORIZATION

Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicants respectfully petition the Commissioner for a one-month extension of time to file a response to an Office Action dated October 3, 2001 (the "Office Action"). Applicants also authorize the Commissioner to charge Deposit Account No. 19-4709 in an amount of \$110.00 for this Petition. This Petition and the response to the Office Action are being filed within three months of the shortened statutory period.

02/27/2002 RHARIS1 00000156 194709 09552540

01 FC:115 110.00 CH

Certificate of Mailing (37 C.F.R. 1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: *Assistant Commissioner for Patents, Washington, D.C. 20231*, on (Date) February 4, 2002.
Typed or printed name of person signing this certificate:

Helen Giglio

Signature: Helen Giglio

Application Serial No.: 09/552,540
February 4, 2002

Kindly charge any additional fees or charges required at this time and in connection with
the present application to Deposit Account No. 19-4709.

Respectfully submitted,

for: David S. Rosenthal Reg. No. 42,518
Lawrence Rosenthal
Registration No. 24,377
Attorney for Applicant
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